

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
MAKOTO KUBOTA ET AL. ) : Examiner: G. Mruk  
Application No.: 10/561,247 ) : Group Art Unit: 2853  
Filed: December 19, 2005 ) : Confirmation No.: 5989  
For: PIEZOELECTRIC THIN FILM, METHOD :  
OF MANUFACTURING PIEZOELECTRIC )  
THIN FILM, PIEZOELECTRIC ELEMENT, :  
AND INK JET RECORDING HEAD ) December 19, 2007  
)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed September 25, 2007, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449.

JP 2003-081694, which was previously cited in the Information Disclosure Statement filed December 19, 2005, was cited in an Official Communication in a corresponding Korean patent application. A copy of the Official Communication is attached.

The item of information in this information disclosure statement was mailed from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

/Mark A. Williamson/

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